

Cr₂O₃ BASED MAGNETOELECTRIC FERRIMAGNET TOWARD MRAM APPLICATIONS

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I. INTRODUCTION

Recently the voltage control of a magnetization direction has received considerable attentions as the technology to achieve an ultra-low power consumption magnetic random access memory (MRAM). One of the promising technologies is the voltage control of a magnetic anisotropy (VCMA) in ferromagnetic metals. Since the dynamic switching of magnetization was demonstrated by utilizing the VCMA effect^{1,2} in MgO-based magnetic tunnel junctions (MTJ), it has been intensively investigated. It is called “voltage torque MRAM”. VCMA value of as large as ~ 300 fJ/Vm was already reported³. Thus it is expected to realize voltage torque MRAM in the not-too-distant future.

The other candidate is that using magnetoelectric (ME) antiferromagnet Cr₂O₃. When we apply parallel (anti-parallel) electric (E) and magnetic field (H), the antiferromagnetic domain of Cr₂O₃ align as $\uparrow\downarrow\uparrow\downarrow$ ($\downarrow\uparrow\downarrow\uparrow$). If we apply fixed positive H , by changing the direction of E from positive to negative, we can switch the direction of surface spin of Cr₂O₃ from up (\uparrow) to down (\downarrow). In addition, the surface spin information can be transferred to neighbor ferromagnet via exchange coupling. Thus by combining both the ME effect and exchange coupling, we can achieve electric control of magnetization. The concept of so called “magnetoelectric random access memory (MERAM)” was proposed in 2006⁴. After that, its primitive operations were demonstrated for Cr₂O₃ bulk^{5,6} and thin film^{7,8} systems. Recently the reduction of the large switching energy was proposed⁹. In additions, ferromagnet free purely antiferromagnetic random access memory was demonstrated¹⁰. These reports make the MERAM more realistic and more interesting. Although Cr₂O₃ is an antiferromagnet, sometimes finite magnetization has been observed for Cr₂O₃ films. We found relative large parasitic magnetic moment, which comparable to the ferrimagnet, for doped Cr₂O₃. In this study, we investigated the parasitic magnetic moments of Al- and Ir-doped Cr₂O₃ film and discussed the usability.

II. EXPERIMENTAL PROCEDURES

The non-dope, Al-doped, and Ir-doped Cr₂O₃ films are fabricated by RF reactive sputtering method. The Al and Ir contents and lattice parameters of the films were confirmed by X-ray fluorescence (XRF) and X-ray diffraction measurements, respectively. Magnetic and magnetoelectric properties were measured by using a superconducting quantum interference device (SQUID) magnetometer or anomalous Hall effect (AHE). The detail of the magnetoelectric properties measurements are described in¹¹. Uncompensated surface spin of Cr₂O₃ film was measured by X-ray magnetic circular dichroism (XMCD) spectroscopy. The XMCD measurements were carried out at beam line BL25SU of the SPring-8 synchrotron radiation facility.

III. RESULTS AND DISCUSSIONS

By Al- and Ir-doping, relative large volume magnetization were obtained. The Cr₂O₃ volume magnetization increase with increasing both Al- and Ir-contents; by about 3.7% Al-(Ir-) dope, volume magnetization of as large as 59 (4.9) emu/cc were obtained, which correspond to 0.61 (0.05) μ_B /Cr. Interestingly, the doped Cr₂O₃ film still exhibit ME properties, and the parasitic magnetization is coupled with the ME order parameter of Cr₂O₃. Fig. 1 shows the ME coefficient α of (a) Al-doped and (b) Ir-doped Cr₂O₃ film against H at 170 K. With increasing applied H , the parasitic magnetization reverse and simultaneously the ME order parameter also reverse. Fig. 1 indicate that in Al-doped sample case, Cr₂O₃ parasitic magnetization is coupled with F⁺ state ($\uparrow\downarrow\uparrow\downarrow$), while in Ir-doped sample case, Cr₂O₃ parasitic magnetization is coupled with F⁻ state ($\downarrow\uparrow\downarrow\uparrow$). These fact were confirmed by combined study of

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magnetization measurements, measurements of Cr_2O_3 surface spin by XMCD, and ME coefficient measurements. These results suggest the parasitic magnetic moment can be controlled by magnetic and electric fields through the ME effect. That is “magnetoelectric ferrimagnet”. XRD results indicate both a and c value expansion for Ir-doped sample, and a and c value compression for Al-doped case. These different kind of lattice strain may related to the difference in Cr_2O_3 volume magnetization direction, since similar magnetization direction change was also observed for Cr_2O_3 films with various buffer layers¹⁰. In this study, we clarified the co-existence of ME and ferrimagnetic properties in doped Cr_2O_3 films. Such an electrically controllable magnetization have a great potential for developing new electric field controlled memory concepts, in additions to the utilization of reduction of ME switching energy⁹.

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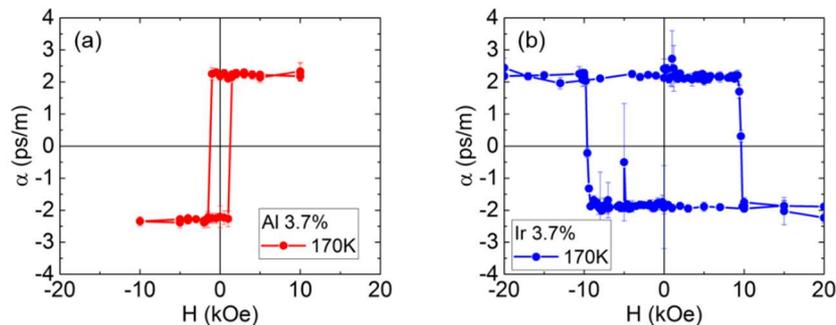


Fig. 1 H dependence of ME coefficient α of (a) Al-doped and (b) Ir doped samples measured at 170K.